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PATENT

Case Docket No. ASMEX.291A

Date: May 6, 2003

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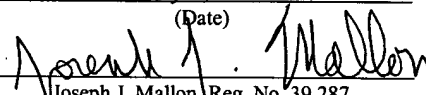
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Todd et al.
Appl. No. : 10/074,563
Filed : February 11, 2002
For : PROCESS FOR DEPOSITION
OF SEMICONDUCTOR FILMS
Examiner : Timothy Howard Meeks
Group Art Unit : 1762

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

May 6, 2003

(Date)


Joseph J. Mallon, Reg. No. 39,287

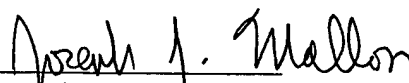
TRANSMITTAL LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application are:

- (X) An Information Disclosure Statement.
- (X) A PTO Form 1449 with one (1) reference.
- (X) The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Account No. 11-1410.
- (X) Return prepaid postcard.


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